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Docket No.: M4065.0316/P316-A
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Gurtej Sandhu, et al.

Examiner: Alexander G. Ghyka

Application No.: 10/684,431

Art Unit: 2812

Filed: October 15, 2003

For: SEMICONDUCTOR DEVICES USING
ANTI-REFLECTIVE COATINGS

RESPONSE TO STATEMENT CONCERNING ALLOWABLE SUBJECT MATTER

Commissioner for Patents
MS: Amendment
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This paper is in filed in response to the Allowable Subject Matter section of the January 31, 2006 Notice of Allowability mailed by the PTO.

While the applicant is in general agreement with the allowable subject matter section, the applicant notes the examiner left out the word "layer" from the statement. In other words the Notice of Allowability stated that "the prior art does not anticipate or make obvious an oxide formed" and should read "the prior art does not anticipate or make obvious an oxide layer formed."

Application No.: 10/684,431

Docket No.: M4065.0316/P316-A

Dated: May 01, 2006

Respectfully submitted,

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